



IEEE 4th International Conference on Computing and Machine  
Intelligence  
April 05-06, 2025  
Central Michigan University

# CERTIFICATE

## of Participation

**This certificate is presented to**  
**Maruf A Dhali**

**For participating and presenting the  
paper titled:**

**Classification and Prediction of Wafer Yield Using  
Gradient Boosting Algorithms: A focus on  
Lithography inline parameters**

A handwritten signature in blue ink, appearing to be "Ah".

**General Chair**  
**Ahmed Abdelgawad, PhD**